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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

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In re application of: FAIR, et al

Attorney Docket No.:  
NOVLP067D2/NVLS-000376D2

Application No.: NEW

Examiner: UNASSIGNED

Filed: HEREWITH

Group: UNASSIGNED

Title: SEQUENTIAL ELECTRON INDUCED  
CHEMICAL VAPOR DEPOSITION

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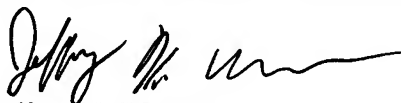
**STATEMENT REQUESTING DELETION OF NON-INVENTOR IN DIVISIONAL  
APPLICATION PURSUANT TO 37 CFR 1.63(d)(2)**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.63(d)(2), please delete Wilbert van den Hoek from the names of inventors in this divisional patent application. Wilbert van den Hoek is not an inventor in this application.

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP



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